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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Takeshi KAJIYAMA

SERIAL NUMBER: 10/787,133

GROUP: 2826

FILED: February 27, 2004

EXAMINER: PERT, EVAN T

FOR: SEMICONDUCTOR DEVICE WITH UPPER PORTION OF PLUGS CONTACTING  
SOURCE AND DRAIN REGIONS BEING A FIRST SELF-ALIGNED SILICIDE

**REQUEST TO CORRECT TITLE OF INVENTION**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request  
correction of your records to reflect the correct title of the invention. The title of the  
invention should read as follows: SEMICONDUCTOR DEVICE **WITH UPPER**  
**PORTION OF PLUGS CONTACTING SOURCE AND DRAIN REGIONS BEING A**  
**FIRST SELF-ALIGNED SILICIDE.**

Respectfully Submitted,

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